



INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(51) International Patent Classification ⁶ : G11B 5/127, G11C 11/15, G01R 33/06, H01L 43/00	A1	(11) International Publication Number: WO 98/25263
		(43) International Publication Date: 11 June 1998 (11.06.98)

(21) International Application Number: PCT/IB97/01399

(22) International Filing Date: 6 November 1997 (06.11.97)

(30) Priority Data:

96203404.7 2 December 1996 (02.12.96) EP

(34) Countries for which the regional or international application was filed: NL et al.

(71) Applicant: PHILIPS ELECTRONICS N.V. [NL/NL]; Groenewoudseweg 1, NL-5621 BA Eindhoven (NL).

(71) Applicant (for SE only): PHILIPS NORDEN AB [SE/SE]; Kottbygatan 7, Kista, S-164 85 Stockholm (SE).

(72) Inventor: LENSSEN, Kars-Michiel, Hubert; Prof. Holstlaan 6, NL-5656 AA Eindhoven (NL).

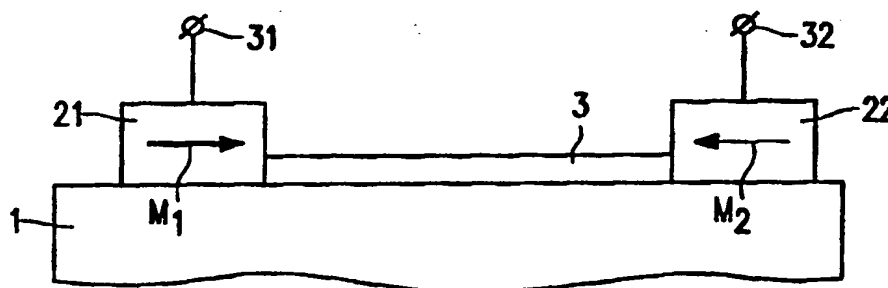
(74) Agent: FAESSEN, Louis, M., H.; Internationaal Octrooibureau B.V., P.O. Box 220, NL-5600 AE Eindhoven (NL).

(81) Designated States: JP, European patent (AT, BE, CH, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE).

Published

*With international search report.**Before the expiration of the time limit for amending the claims and to be republished in the event of the receipt of amendments.*

(54) Title: LATERAL MAGNETO-ELECTRONIC DEVICE EXPLOITING A QUASI-TWO-DIMENSIONAL ELECTRON GAS



(57) Abstract

A magneto-electronic device comprising a substrate (1) on which a first body (21) and a second body (22) of magnetic material are provided, whereby the magnetization (M_2) of at least the second body (22) is not fixed, the two bodies (21, 22) being substantially coplanar and mutually isolated, and being mutually connected via a layer (3) of semi-conductor material in which a quasi-two-dimensional electron gas can be generated.

FOR THE PURPOSES OF INFORMATION ONLY

Codes used to identify States party to the PCT on the front pages of pamphlets publishing international applications under the PCT.

AL	Albania	ES	Spain	LS	Lesotho	SI	Slovenia
AM	Armenia	FI	Finland	LT	Lithuania	SK	Slovakia
AT	Austria	FR	France	LU	Luxembourg	SN	Senegal
AU	Australia	GA	Gabon	LV	Latvia	SZ	Swaziland
AZ	Azerbaijan	GB	United Kingdom	MC	Monaco	TD	Chad
BA	Bosnia and Herzegovina	GE	Georgia	MD	Republic of Moldova	TG	Togo
BB	Barbados	GH	Ghana	MG	Madagascar	TJ	Tajikistan
BE	Belgium	GN	Guinea	MK	The former Yugoslav Republic of Macedonia	TM	Turkmenistan
BF	Burkina Faso	GR	Greece			TR	Turkey
BG	Bulgaria	HU	Hungary	ML	Mali	TT	Trinidad and Tobago
BJ	Benin	IE	Ireland	MN	Mongolia	UA	Ukraine
BR	Brazil	IL	Israel	MR	Mauritania	UG	Uganda
BY	Belarus	IS	Iceland	MW	Malawi	US	United States of America
CA	Canada	IT	Italy	MX	Mexico	UZ	Uzbekistan
CF	Central African Republic	JP	Japan	NE	Niger	VN	Viet Nam
CG	Congo	KE	Kenya	NL	Netherlands	YU	Yugoslavia
CH	Switzerland	KG	Kyrgyzstan	NO	Norway	ZW	Zimbabwe
CI	Côte d'Ivoire	KP	Democratic People's Republic of Korea	NZ	New Zealand		
CM	Cameroon		Republic of Korea	PL	Poland		
CN	China	KR	Republic of Korea	PT	Portugal		
CU	Cuba	KZ	Kazakhstan	RO	Romania		
CZ	Czech Republic	LC	Saint Lucia	RU	Russian Federation		
DE	Germany	LI	Liechtenstein	SD	Sudan		
DK	Denmark	LK	Sri Lanka	SE	Sweden		
EE	Estonia	LR	Liberia	SG	Singapore		

"Lateral magneto-electronic device exploiting a quasi-two-dimensional electron gas"

The invention relates to a magneto-electronic device comprising a substrate on which a first and a second body of magnetic material are provided, whereby the magnetization of at least the second body is not fixed.

The term "body" should here be interpreted as encompassing such objects as, for example, individual thin films, multilayer structures or thick films, all of which at least partially comprise magnetic material. The term "fixed" as employed with regard to magnetization has a relative meaning: the magnetization M_1 in a first body is fixed with respect to the magnetization M_2 in a second body if the external magnetic field strength H required to directionally reverse M_1 is higher than that required to reverse M_2 . One way of fixing the magnetization direction in a magnetic body is to exchange-bias it; alternatively, if the coercive field of the first body exceeds that of the second, or if the first body has a larger shape anisotropy, then the magnetization of the first body may be regarded as being fixed.

A device as specified in the opening paragraph is known from International Patent Application WO 95/22820, which describes a trilayer structure comprising two layers of magnetic material which are separated by and magnetically coupled across an interposed non-metallic layer (comprising, for example, a semiconductor, semi-metal or insulator material). One of the layers of magnetic material has a fixed magnetization direction — achieved using a technique such as exchange-biasing, for example — whereas the magnetization in the other magnetic layer is free to rotate. By connecting the magnetic layers to opposite poles of a controllable voltage source, an electric field can be applied across the non-metallic interlayer; in this manner, the strength and nature of the magnetic coupling across the interlayer can be altered, thereby allowing alteration of the relative orientation of the magnetizations in the two magnetic layers. Exploiting this effect, the device can, for example, be employed as a magnetic write head or a magnetic random-access memory (MRAM).

The known device has a number of disadvantages. For example, the voltages required to alter the coupling across the interlayer (typically of the order of five

volts, or more) are relatively high. In addition, because of the stacked nature of the device, the distance between the magnetic layers is relatively small (of the order of a few nanometers), so that the interlayer cannot be accessed directly in order to influence its properties in a more refined or localized manner.

5

It is an object of the invention to provide a new type of magneto-electronic device. In particular, it is an object of the invention that the constituent parts of this device be more accessible, so as to allow more refined influencing of the device's performance. In addition, it is an object of the invention that it be possible to influence the properties of the new device using not only an electric field but also various other agents. Moreover, it is an object of the invention that the new device should have a lower operating voltage than the known device.

These and other objects are achieved according to the invention in a device as specified in the opening paragraph, characterized in that the two bodies are substantially coplanar and mutually isolated, and that the bodies are mutually connected *via* a layer of semiconductor material in which a quasi-two-dimensional electron gas can be generated.

The term "two-dimensional electron gas" (2DEG) is used in reference to semiconductor structures in which, within a given plane, there is a relatively high (metallic) electron mobility, whereas, perpendicular to that plane, electrons are trapped in a potential well. 2DEGs are exploited in ordinary MOSFETs, for example, but their application in a device as specified in the previous paragraph has heretofore been unknown. The physics of 2DEGs is elucidated in brief in United States Patent US 4,996,570, and in greater detail in *Solid State Physics*, vol. 44, H. Ehrenreich and D. Turnbull (Eds.), Academic Press Inc., 1991, ISBN 0-12-607744-4, particularly pages 1-26. In a so-called "true 2DEG", only one sub-band in the potential well is occupied, and there is no scattering to higher sub-bands; on the other hand, in a so-called "quasi-2DEG", several sub-bands in the potential well are occupied (the mutual separation of the sub-bands being greater than the thermal energy kT at any given temperature T , where k is the Boltzmann constant). Throughout this text, the term "quasi-2DEG" or "quasi-two-dimensional electron gas" should be interpreted as encompassing true 2DEGs also. Some semiconductor structures contain an "intrinsic" quasi-2DEG which is present even in the absence of an applied electric field, whereas other structures demonstrate quasi-2DEG behaviour only in the presence of such a field: for this

reason, the phrase "can be generated" as here employed should be interpreted as encompassing both of these possibilities.

The invention exploits *inter alia* the facts that a quasi-2DEG has a relatively large electronic mean free path (of the order of 0.2-0.5 μm) and a relatively high electron mobility (typically greater than 1.5 m^2/Vs); consequently, the quasi-2DEG can, for example, mediate magnetic coupling between two magnetic bodies over a relatively large distance, allowing a lateral device geometry instead of the conventional stacked geometry. In addition, it is possible to modulate the electron density of a quasi-2DEG, while still preserving its metallic properties; as a result, if two magnetic bodies are only mutually connected *via* the quasi-2DEG, then magnetic interaction (coupling) between those bodies can be altered by adjusting the quasi-2DEG's electron density. Because of the said lateral geometry, the semiconductor layer in which the quasi-2DEG is generated can be freely accessed by actinic radiation beams, magnetic fields or gate electrodes, so that the quasi-2DEG's electron density can be influenced in a direct, localized and refined manner. In the case of adjustment with one or more gate electrodes, the voltages typically required (of the order of 1 volt) are substantially lower than those required in the known device. In addition, because it is freely accessible, the semiconductor layer can be structured into various forms (*e.g.* using lithographic techniques), so that its electrical resistance can be tailored to the requirements of a particular application (*e.g.* the layer can be endowed with a constriction, resulting in a high electrical resistance between the magnetic bodies). As will be elucidated in more detail hereunder, the device according to the invention can be used as the basis of magnetic field sensors, magnetic write heads, MRAMs, *etc.*

It should be noted that, in the device according to the invention, the layer of semiconductor material in which the quasi-2DEG is generated may, for example, be disposed only in the gap between the two isolated magnetic bodies, or it may be disposed as a layer on top of the substrate and beneath the magnetic bodies. It should also be explicitly noted that the inventive device is suitable for operation at room temperature, and therefore does not need to be cooled to cryogenic temperatures in order to work.

An advantageous embodiment of the device according to the invention is characterized in that the magnetization direction of the first body is fixed (using, for example, a technique as elucidated in the second opening paragraph). As will be elucidated in what follows, this measure lies at the heart of several of the inventive device's possible applications. However, it should be noted that M_1 does not necessarily have to be fixed: for example, the device according to the invention can still be used as a type of MRAM if both

M_1 and M_2 are free to rotate: see (d) below.

A particular embodiment of the inventive device as specified in the previous paragraph is characterized in that the first and second body are mutually magnetically coupled (exchange-coupling or magnetostatic coupling). In such a case, seeing
5 as the magnetization M_2 of the second body is not fixed but that the magnetization M_1 of the first body is fixed, it is possible to alter the relative orientation of M_1 and M_2 simply by changing the nature (sign) of the coupling between them. This opens up several possible applications for the inventive device, including, for example:

(a) A magnetic write head:

10 By using an electric field or a light source to modulate the electron density in the semiconductor layer's quasi-2DEG according to a given binary data pattern, the coupling between the two magnetic bodies can be altered back and forth between ferromagnetic (F) and anti-ferromagnetic (AF) states, causing M_2 to correspondingly rotate back and forth so as to
15 be parallel or anti-parallel to M_1 , respectively. This modulation of the direction of M_2 can be used to write binary information on a neighbouring magnetic medium, such as a tape, disc or card;

(b) An MRAM:

20 As in the above case, application or removal of an electric field (for example) to the semiconductor layer can be used to change the direction of M_2 . In this manner, the inventive device can be used as a binary RAM, whereby one direction of M_2 represents a "0" and the opposite direction represents a "1". The particular binary bit represented by M_2 at a given time can, for example, be determined (read) by monitoring magneto-
25 optical Kerr effects in the second body, or by embodying the second body as a spin-valve magneto-resistive trilayer and monitoring its electrical resistance. A specific advantage of the inventive device's lateral geometry in the case of an MRAM is that, because the first and second magnetic bodies can be further apart than in the case of a stacked structure, it is
30 possible to influence one magnetic body (e.g. with a current carrying wire) without substantially influencing the other magnetic body.

Such devices will be elucidated in more detail in the Embodiments below.

In an alternative embodiment of the inventive device as specified in the previous paragraph, the first and second body are not mutually magnetically coupled.

Possible applications for such a device include, for example:

(c) A magnetic field sensor (magnetic read head):

The device according to the invention demonstrates a substantial spin-valve magneto-resistance effect. In the absence of coupling between the first and second bodies, M_2 is free to rotate in response to a variable external magnetic flux. Since M_1 is directionally fixed, such rotation will continually change the mutual orientation of M_1 and M_2 , and thus the electrical resistance between the first and second magnetic bodies. The device thus acts as a transducer, translating a variable magnetic flux into a correspondingly varying electrical signal;

(d) An MRAM:

If both M_1 and M_2 are free to rotate, then an MRAM can be realized by employing two separate write lines (*i.e.* electrical tracks with which a magnetic field can be generated) to directly manipulate M_1 and M_2 separately. In this manner, M_1 and M_2 can be switched between parallel and anti-parallel configurations, thereby accordingly influencing the lateral electrical resistance R_{12} of the MRAM (*via* the spin-valve magneto-resistance effect).

Such devices will be elucidated in more detail in the Embodiments below.

As has been demonstrated hereabove, various possible applications of the inventive device exploit the application of an electric field to the quasi-2DEG. A convenient way to produce such a (controllable) field is with the aid of an electrode (a so-called gate electrode or Schottky contact) provided against the layer of semiconductor material. In particular, if so desired or required, several such gate electrodes may be provided against the semiconductor layer, thus allowing different regions of the quasi-2DEG to be subjected to different electric fields; this allows, for example, the creation of a so-called resonant-tunnelling multiple-barrier structure in the quasi-2DEG (a lateral version of a device as elucidated in International Patent Application WO 96/11469). In addition, if so desired, the gate electrode(s) may be endowed with a particular geometrical form (*e.g.* using lithographic techniques).

In the embodiment elucidated in the previous paragraph, the gate electrode(s) may be provided in direct contact with the semiconductor layer. Alternatively, the gate electrode(s) may be electrically insulated from the layer of semiconductor material. Such insulation may, for example, be achieved by providing a layer of dielectric material

(such as SiO_2) between the gate electrode(s) and the semiconductor layer. A separate insulating layer of this type is not necessary if, for example, there is a quantum well structure (*i.e.* a non-conductive (surface) layer) in the semiconductor layer in which the quasi-2DEG is generated.

5 In general, at least one of the magnetic bodies in the inventive device will be connected to an electrical terminal, and, if required by a particular application, both magnetic bodies can be connected to different electrical terminals. However, if so desired, the inventive device may also comprise other ohmic contacts (terminals). For example, using a total of four contacts (*e.g.* on a single sheet of quasi-2DEG semiconductor material), one
10 can make a planar Hall-effect device, in which the current-flow between two magnetic contacts is substantially perpendicular to the voltage gradient measured between two metallic contacts; such a device (excepting that it does not employ a quasi-2DEG) is, for example, elucidated by A. Schuhl *et al.* in Appl. Phys. Lett. 66 (1995), pp 2751-2753. Use of the Hall geometry in, for example, a magnetic field sensor employing the inventive device allows a
15 significant noise reduction to be achieved.

For optimal performance, the occurrence of Schottky barriers at the interface between the magnetic bodies and the semiconductor layer should be avoided. In this light, an advantageous embodiment of the device according to the invention is characterized in that the semiconductor material comprises InAs. InAs demonstrates an accumulation layer
20 at its surface (forming a quasi-2DEG), so that most metals deposited on clean InAs will form an ohmic contact. A suitable alternative to pure InAs is, for example, $\text{In}_x\text{Ga}_{1-x}\text{As}$ (in which the quantity of Ga is relatively small, *e.g.* $x \geq 0.8$).

Suitable substrate materials for use in the device according to the invention include, for example, silicon wafers and InP, among others. Suitable magnetic
25 materials for use in the first and second magnetic bodies include, for example, Fe, Ni, Co, various binary and ternary alloys of these materials (such as permalloy), CoZrNb and FeNbZrN, among others. It should be noted that the first and second magnetic bodies need not have the same constitution, shape or dimensions.

30

The invention and its attendant advantages will be further elucidated with the aid of exemplary embodiments and the accompanying schematic drawings, whereby:

Figure 1 renders a cross-sectional view of a semiconductor layer in which a quasi-2DEG can be generated;

Figure 2 is a cross-sectional depiction of a device according to the invention, here embodied as a magnetic field sensor;

Figure 3 depicts a modification of the subject of Figure 2, suitable for use as a magnetic write head;

Figure 4 depicts a modification of the subject of Figure 2, suitable for use as an MRAM;

Corresponding features in the various Figures are denoted by the same reference symbols.

Embodiment 1

Figure 1 renders a cross-sectional view of a particular embodiment of a semiconductor layer 3 which is suitable for use in a device according to the invention and in which a quasi-2DEG can be generated. The layer 3 is deposited on a substrate 1, which in this case is comprised of InP. The layer 3 has a composite structure, with the following composition:

item	material	thickness
5	ud InAlAs	200 nm
7	n ⁺ InAlAs	7 nm
9	ud InAlAs	6 nm
11	ud InGaAs	2.5 nm
13	ud InAs	4 nm
15	ud InGaAs	13.5 nm
17	ud InAlAs	20 nm

In the table, "ud" indicates un-doped (*i.e.* intrinsic), and "n⁺" indicates donor-doping.

The depicted semiconductor layer 3 contains a quasi-2DEG in constituent layer 13 (in this particular case, a true, intrinsic 2DEG). This quasi-2DEG has an electron mobility of approx. 1.65 m²/Vs, an electron density of approx. $1.96 \times 10^{16} \text{ m}^{-2}$ and an electronic mean free path of approx. 0.4 μm .

Embodiment 2

As an example of an alternative to the structure in Embodiment 1, a quasi-2DEG can also be generated in an MBE-grown semiconductor layer constituted as follows:

ud GaAs (17 nm)
 n-doped Al_{0.33}Ga_{0.67}As (38 nm)
 ud Al_{0.33}Ga_{0.67}As (41 nm)
 ud GaAs (500 nm)

These constituents are listed in order of decreasing distance to the substrate, which may be comprised of GaAs, for example. The figures in parentheses indicate ideal thicknesses for the various constituents. The symbol "ud" indicates un-doped (*i.e.* intrinsic).

Embodiment 3

Figure 2 shows a particular embodiment of a device according to the invention. The device comprises a substrate 1 on which a first magnetic body 21 and second magnetic body 22 are provided. The first body 21 has a magnetization M₁ and is connected to an electrical terminal 31, whereas the second body 22 has a magnetization M₂ and is connected to an electrical terminal 32. The bodies 21,22 may be comprised of permalloy, for example. As here depicted, the magnetizations M₁, M₂ have an in-plane direction, but they may also stand perpendicular to the substrate 1, for example (perpendicular anisotropy).

The magnetization M₂ is free to rotate under the influence of an external magnetic flux. However, the magnetization M₁ is directionally fixed by exchange-biasing the body 21 to an adjacent layer of exchange-biasing material, such as Fe₅₀Mn₅₀, which may, for example, be deposited on top of the body 21. Alternatively, the body 21 can be embodied to have a higher coercivity H_c than the body 22, *e.g.* by using different base materials for

the bodies 21,22, or by using the same base material and doping it to different extents with a H_c -influencing additive (such as Os or Re). Yet another alternative is to endow the bodies 21,22 with different shape anisotropies, *e.g.* by embodying 22 as a disc (low shape anisotropy).

5 The first and second bodies 21,22 are mutually connected *via* a layer 3 of semiconductor material in which a quasi-2DEG can be generated (*e.g.* the layer 3 described in Embodiment 1). The arrangement of the bodies 21,22 and the layer 3 is such as to form a lateral configuration instead of a trilayer stack. The lateral distance between the bodies 21,22 is preferably of the same order of magnitude as the quasi-2DEG's electronic mean free path
10 (typically about 0.2-0.5 μm). As here depicted, the layer 3 lies between the bodies 21,22; however, it may also lie under the bodies, as long as it provides a mutual connection.

12 The lateral separation of the bodies 21,22 is so large as to deter magnetic coupling between them. This will typically be the case for lateral separations of the order of about 0.25 - 0.5 μm , or more.

15 The sensor demonstrates a substantial spin-valve magneto-resistance effect, whereby the value of the electrical resistance R_{12} measured between the terminals 31 and 32 depends on the relative orientation of M_1 and M_2 (in particular, whether they are parallel or anti-parallel). Exposure of the sensor to a variable external magnetic flux will
20 cause M_2 to change its direction. Since M_1 is fixed, such exposure will change the relative orientation of M_1 and M_2 , and thus also the value of R_{12} . In this way, a variable external magnetic flux can be converted into a correspondingly varying electrical signal, so that the device acts as a magnetic field sensor. In a particular application, the external magnetic flux emanates from a magnetic registration medium, such as a magnetic tape, disc or card moving
25 in close proximity to the body 22, whence the device acts as a magnetic read head.

25 The device as depicted in Figure 2 may, of course, comprise additional parts to those depicted. In particular, the device may comprise flux guides, so as to concentrate external magnetic flux into the vicinity of the body 22.

30 Embodiment 4

Figure 3 basically shows the device of Figure 2, subsequent to some modification. In particular:

- a gate electrode 23 has been provided against (upon) the layer 3, and this

electrode 23 is connected to an electrical terminal 33;

- the terminals 31,32 in Figure 2 are absent in the present case;
- the magnetic bodies 21,22 are magnetically coupled. This may be realized by ensuring a sufficiently small lateral separation of the bodies 21,22 (*e.g.* of the order of about 100 nm).

As here depicted, the gate electrode 23 is in direct contact with the layer 3, but electrode 23 and layer 3 may also be mutually separated by an interposed layer of electrically insulating material (not depicted).

By applying an electrical voltage to the terminal 33, the layer 3 can be subjected to an electric field *via* the electrode 23, and this field can be used to alter the electron density of the quasi-2DEG in the layer 3. In particular, it is possible in this manner to alter the strength and/or sign (type) of the coupling between the bodies 21,22.

In a particular example, the coupling between the bodies 21,22 is intrinsically ferromagnetic (*e.g.* as a result of an exchange interaction), so that the magnetizations M_1 and M_2 are mutually parallel in the absence of an external magnetic flux. By applying a small DC voltage (of the order of 1 volt) to the terminal 33, the quasi-2DEG in the layer 3 is locally subjected to an electric field, causing the coupling between the bodies 21,22 to become antiferromagnetic (*e.g.* by electronically depleting the quasi-2DEG, so that the coupling between the bodies 21,22 becomes magnetostatic); as a result, since M_1 is fixed, M_2 will reverse its direction so as to be anti-parallel to M_1 .

It is thus seen that application of a variable voltage to the terminal 33 can be used to cause the magnetization M_2 to flip back and forth in direction. Therefore, if a magnetic recording medium is moved close to the body 22 (or to the pole face of a flux guide emanating therefrom), then application of a data-modulated voltage to the terminal 33 can be used to encrypt the medium with the said data, by virtue of the magnetic influence of M_2 on the medium. The device can thus be used as a magnetic write head.

Embodiment 5

Figure 4 basically shows the device of Figure 2, subsequent to some modification. In particular, a so-called "write-line" 34 has been provided against the body 22, and is separated therefrom by a layer 35 of electrically insulating material, such as Si_3N_4 . In this particular case, the write line 34 extends in a direction perpendicular to the

plane of the Figure, and is comprised of a conductive material such as Cu or Au, for example.

5 An electrical current flowing through the write line 34 will produce a magnetic field with which the direction of M_2 can be influenced; in particular, M_2 can be directionally reversed back and forth. Since M_1 is fixed, such a change in the direction of M_2 causes a change in the mutual orientation of M_1 and M_2 , which can be monitored by measuring the resistance R_{12} between the terminals 31 and 32.

10 In this manner, the device acts as a magnetic random-access memory in which binary data can be stored and from which they can be retrieved again: a maintained voltage corresponding to a "1" or "0" on the write line 34 produces a parallel or anti-parallel configuration of M_1 and M_2 , which in turn results in a relatively low or high value of R_{12} .

If so desired, the device depicted in Figure 4 can be incorporated into an array of such devices, so as to be able to store and retrieve multiple data bits.

CLAIMS

1. A magneto-electronic device comprising a substrate on which a first and a second body of magnetic material are provided, whereby the magnetization of at least the second body is not fixed, characterized in that the two bodies are substantially coplanar and mutually isolated, and that the bodies are mutually connected *via* a layer of semiconductor material in which a quasi-two-dimensional electron gas can be generated.
2. A device according to Claim 1, characterized in that the magnetization direction of the first body is fixed.
3. A device according to Claim 2, characterized in that the first and second body are mutually magnetically coupled.
4. A device according to Claim 2, characterized in that the first and second body are not mutually magnetically coupled.
5. A device according to any of the Claims 1-4, characterized in that an electrode is provided against the layer of semiconductor material.
6. A device according to Claim 5, characterized in that the electrode is electrically insulated from the layer of semiconductor material.
7. A device according to any of the Claims 1-6, characterized in that the semiconductor material comprises InAs.
8. A magnetic field sensor comprising a device as claimed in any of the Claims 1-7.
9. A magnetic write head comprising a device as claimed in any of the Claims 1-8.
10. A magnetic random-access memory comprising a device as claimed in any of the Claims 1-7.

1/2

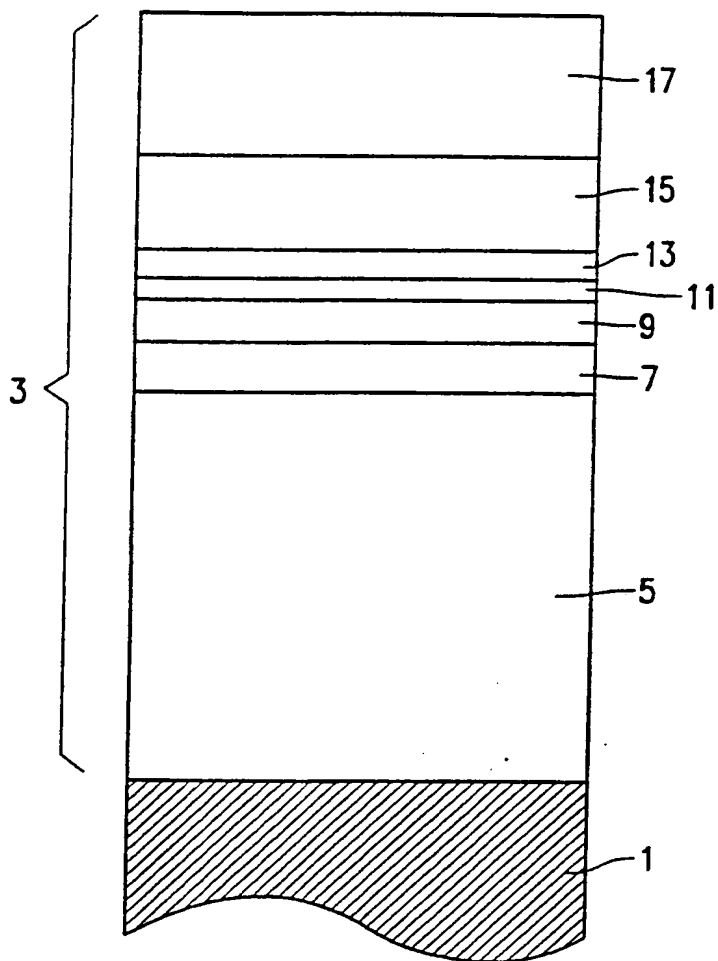


FIG. 1

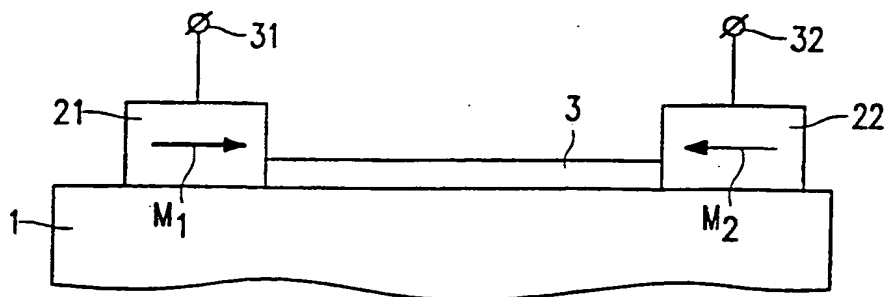


FIG. 2

2/2

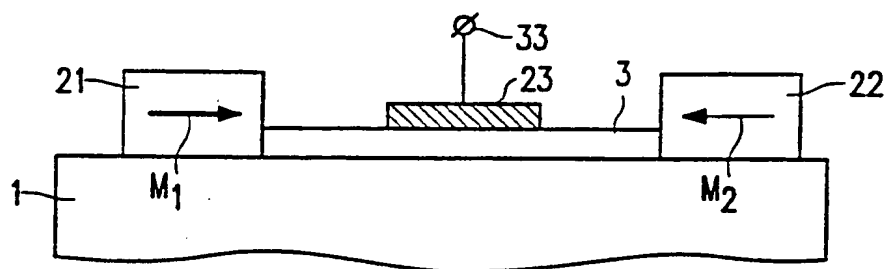


FIG. 3

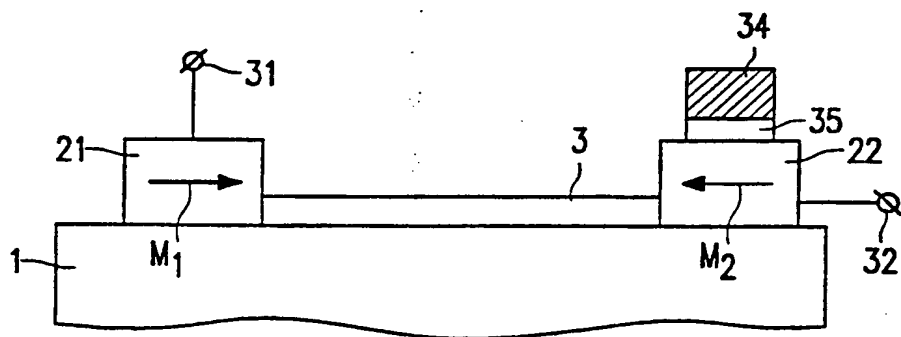


FIG. 4

INTERNATIONAL SEARCH REPORT

International application No.

PCT/IB 97/01399

A. CLASSIFICATION OF SUBJECT MATTER

IPC6: G11B 5/127, G11C 11/15, G01R 33/06, H01L 43/00
According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC6: G01R, G11B, G11C, H01L

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

SE,DK,FI,NO classes as above

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)

CLAIMS, WPI, INSPEC

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
P,X	US 5654566 A (MARK B. JOHNSON), 5 August 1997 (05.08.97), column 7, line 41 - column 9, line 12; column 10, line 11 - column 14, line 31 --	1-10
Y	US 5565695 A (MARK B. JOHNSON), 15 October 1996 (15.10.96), column 7, line 60 - column 10, line 21 --	1-3,5,8-10
Y	US 5432373 A (MARK B. JOHNSON), 11 July 1995 (11.07.95), column 2, line 51 - column 8, line 19 --	1-3,5,8-10

☒ Further documents are listed in the continuation of Box C.☒ See patent family annex.

* Special categories of cited documents:

- "A" document defining the general state of the art which is not considered to be of particular relevance
 "E" earlier document but published on or after the international filing date
 "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
 "O" document referring to an oral disclosure, use, exhibition or other means
 "P" document published prior to the international filing date but later than the priority date claimed

"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention.

"X" document of particular relevance: the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone

"Y" document of particular relevance: the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art

"&" document member of the same patent family

Date of the actual completion of the international search

22 April 1998

Date of mailing of the international search report

24.04.98

Name and mailing address of the ISA/
 Swedish Patent Office
 Box 5055, S-102 42 STOCKHOLM
 Facsimile No. +46 8 666 02 86

Authorized officer

Bo Gustavsson
 Telephone No. +46 8 782 25 00

INTERNATIONAL SEARCH REPORT

International application No.

PCT/IB 97/01399

C (Continuation). DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	Applied Physics Letters, Volume 56, No 7, February 1990, Supriyo Datta, Biswajit Das, "Electronic analog of the electro-optic modulator" page 665 - page 667 ---	1-10
A	EP 0450912 A2 (HONEYWELL INC.), 9 October 1991 (09.10.91), see the whole document -- -----	1-10

INTERNATIONAL SEARCH REPORT

Information on patent family members

02/04/98

International application No.

PCT/IB 97/01399

Patent document cited in search report			Publication date	Patent family member(s)		Publication date
US	5654566	A	05/08/97	US	5565695 A	15/10/96
				US	5629549 A	13/05/97
				US	5652445 A	29/07/97

US	5565695	A	15/10/96	US	5652445 A	29/07/97
				US	5654566 A	05/08/97
				US	5629549 A	13/05/97

US	5432373	A	11/07/95	NONE		

EP	0450912	A2	09/10/91	CA	2038469 A	05/10/91
				DE	69120137 D,T	23/01/97
				JP	5101641 A	23/04/93
				US	5012444 A	30/04/91

Docket # MUH-12777

Applic. # _____

Applicant: GEORG SCHMIDT ET AL.

Lerner and Greenberg, P.A.

Post Office Box 2480

Hollywood, FL 33022-2480

Tel: (954) 925-1100 Fax: (954) 925-1101